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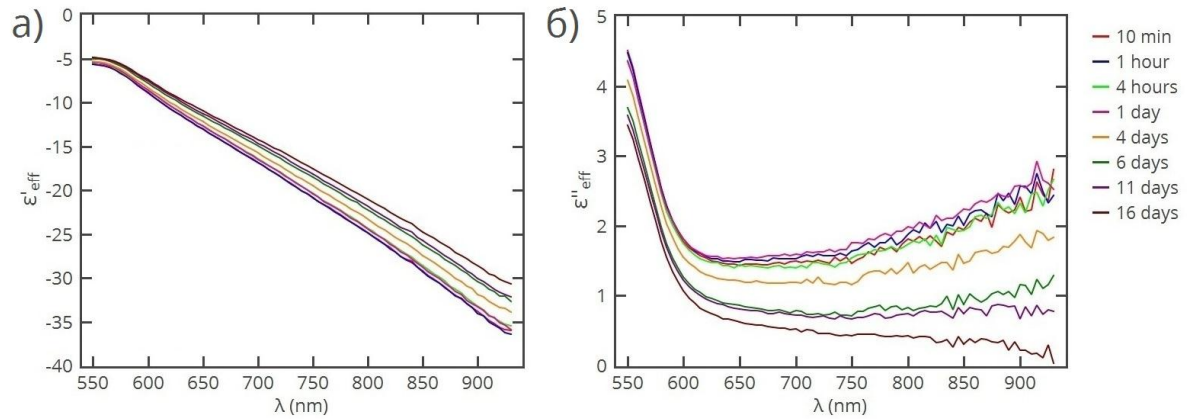
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(<100 )

[1].

$k$  [2].

( . . . 1( , )).



. 1.

' $\epsilon'_{\text{eff}}$  ( )

" $\epsilon''_{\text{eff}}$  ( )

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